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Assistant Commissioner for Patents,

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TOWNSEND and TOWNSEND and CREW LLP

By Jeje L. Chrock

PATENT Attorney Docket No.: AM1126D1/T08910



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:) Examiner: Unassigned
Kramadhati V. Ravi et al) Art Unit: 2812
Application No.: 09/362,504)) <u>CHANGE OF CORRESPONDENCE</u>
Filed: July 27, 1999) ADDRESS
For: Method For Reducing The Intrinsic Stress of High Density Plasma Films)) 3)

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Please change the correspondence address for the above-identified application as follows:

Patent Counsel 3050 Bowers Avenue P.O. Box 450A Santa Clara, CA 95052

Respectfully submitted,

Joshua D. Isenberg

Patent Agent

Reg. No. 41,088

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